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Bib Data Sheet

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| SERIAL NUMBER 09/926,464 | FILING DATE 01/10/2002 RULE | CLASS 257 | GROUP ART UNIT 2826 | ATTORNEY DOCKET NO. 215811US0PCT | |
| APPLICANTS Yasuji Hiramatsu, Ibi-gun, JAPAN; Yasutaka Ito, Ibi-gun, JAPAN; Atsushi Ozaki, Ibi-gun, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP01/01787 03/07/2001 ** FOREIGN APPLICATIONS ***** JAPAN 2000-61901 03/07/2000 | | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i> | STATE OR COUNTRY JAPAN | SHEETS DRAWING 12 | TOTAL CLAIMS 5 | INDEPENDENT CLAIMS 1 |
| ADDRESS 22850 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 | | | | | |
| TITLE Ceramic substrate for manufacture/inspection of semiconductor | | | | | |
| FILING FEE RECEIVED 1128 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) | | |

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